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N. Whiter  
7/22/99  
Patent

Docket No.: 29273/502

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANTS : KAWANO, Hajime et al. ✓  
SERIAL NO. : 09/315,988 ✓  
FILED : May 21, 1999 ✓  
FOR : Electron Beam Lithography System ✓

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ASSISTANT COMMISSIONER  
FOR PATENTS  
Washington, DC 20231

**INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. § 1.97(b)**

SIR:

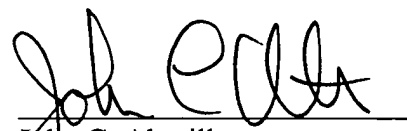
In conformance with Applicants' duty of disclosure under 37 C.F.R. § 1.56(a) and § 1.97(b)(3), the references listed on the attached form PTO-1449 are hereby brought to the Examiner's attention.

In accordance with the requirements of 37 C.F.R. § 1.98, copies of the references are submitted herewith.

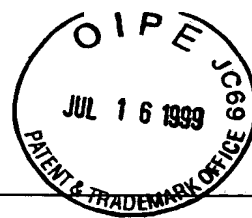
It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear in the "references cited" on any patent to issue therefrom.

Respectfully submitted,

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Date: July 14, 1999

  
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#4

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>	ATTY. DOCKET NO. <b>29273/502</b>	SERIAL NO. <b>09/315,988</b>
	APPLICANT <b>KAWANO, Hajime et al.</b>	
	FILING DATE <b>May 21, 1999</b>	GROUP <b>2878</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	CLASS/ SUBCLASS	FILING DATE
	5,051,598	09/24/91	Ashton et al.	250/492.2	09/12/90

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION	
					YES	NO
	52-119078		Japan		X	
	63-001032		Japan		X	
	4-258111		Japan			X

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	<b>RECEIVED</b>
	<b>JUL 19 1999</b>

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EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation is considered, whether or not citation is in conformance with M.P.E.P. 609; strike out citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

195983:29273/502(jeb)